

PAPER • OPEN ACCESS

Flexible UV detectors based on *in-situ* hydrogen doped amorphous Ga₂O₃ with high photo-to-dark current ratio

To cite this article: Yanxin Sui *et al* 2024 *Mater. Futures* **3** 015701

View the [article online](#) for updates and enhancements.

You may also like

- [Hydrogen-included plasma-assisted reactive sputtering for conductivity control of ultra-wide bandgap amorphous gallium oxide](#)
Kosuke Takenaka, Hibiki Komatsu, Taichi Sagano et al.
- [A flexible and transparent -Ga₂O₃ solar-blind ultraviolet photodetector on mica](#)
Yanxin Sui, Huili Liang, Wenxing Huo et al.
- [Insulator-to-semiconductor conversion of solution-processed ultra-wide bandgap amorphous gallium oxide via hydrogen annealing](#)
Diki Purnawati, Juan Paolo Bermundo and Yukiharu Uraoka

Flexible UV detectors based on *in-situ* hydrogen doped amorphous Ga₂O₃ with high photo-to-dark current ratio

Yanxin Sui^{1,2}, Huili Liang^{1,2,*} , Wenxing Huo³, Xiaozhi Zhan⁴, Tao Zhu^{1,2,4} and Zengxia Mei^{1,2,*}

¹ Songshan Lake Materials Laboratory, Dongguan, Guangdong 523808, People's Republic of China

² Institute of Physics, Chinese Academy of Sciences, Beijing 100190, People's Republic of China

³ Department of Biomedical Engineering, Tianjin University, 92 Weijin Road, Tianjin 300072, People's Republic of China

⁴ China Spallation Neutron Source, Dongguan, Guangdong 523803, People's Republic of China

E-mail: hliang@iphy.ac.cn and zxmei@iphy.ac.cn

Received 28 September 2023, revised 5 December 2023

Accepted for publication 29 December 2023

Published 18 January 2024



Abstract

Amorphous Ga₂O₃ (a-Ga₂O₃) has been attracting more and more attention due to its unique merits such as wide bandgap (~ 4.9 eV), low growth temperature, large-scale uniformity, low cost and energy efficient, making it a powerful competitor in flexible deep ultraviolet (UV) photodetection. Although the responsivity of the ever-reported a-Ga₂O₃ UV photodetectors (PDs) is usually in the level of hundreds of A/W, it is often accompanied by a large dark current due to the presence of abundant oxygen vacancy (V_O) defects, which severely limits the possibility to detect weak signals and achieve versatile applications. In this work, the V_O defects in a-Ga₂O₃ thin films are successfully passivated by *in-situ* hydrogen doping during the magnetron sputtering process. As a result, the dark current of a-Ga₂O₃ UV PD is remarkably suppressed to 5.17×10^{-11} A at a bias of 5 V. Importantly, the photocurrent of the corresponding device is still as high as 1.37×10^{-3} A, leading to a high photo-to-dark current ratio of 2.65×10^7 and the capability to detect the UV light with the intensity below 10 nW cm^{-2} . Moreover, the H-doped a-Ga₂O₃ thin films have also been deposited on polyethylene naphtholate substrates to construct flexible UV PDs, which exhibit no great degradation in bending states and fatigue tests. These results demonstrate that hydrogen doping can effectively improve the performance of a-Ga₂O₃ UV PDs, further promoting its practical application in various areas.

Supplementary material for this article is available [online](#)

Keywords: Ga₂O₃, hydrogen doping, ultraviolet photodetector, photo-to-dark current ratio, neutron reflection

* Authors to whom any correspondence should be addressed.



Original content from this work may be used under the terms of the [Creative Commons Attribution 4.0 licence](#). Any further distribution of this work must maintain attribution to the author(s) and the title of the work, journal citation and DOI.

1. Introduction

Deep ultraviolet (UV) detection has broad applications in the field of space communication, flame pre-warning, biomedicine, missile guidance, ozone monitoring and power system safety [1–3]. As a natural deep UV detecting material, amorphous Ga_2O_3 (a- Ga_2O_3) owns many advantages such as suitable bandgap of ~ 4.9 eV with no need of intentional alloying, comparable photoresponsivity with its crystalline counterpart, homogeneity without crystal grains and large-area preparation at room temperature, making it a promising candidate in practical applications. [4–8] To feasibly capture ultra-weak UV light in most usage scenarios, a competent UV photodetector (PD) must possess performance with low dark current and high responsivity simultaneously, that is, high photo-to-dark current ratio (PDCR). However, the ultra-high responsivity (usually in the level of hundreds of A/W) of a- Ga_2O_3 UV PDs with simple metal–semiconductor–metal (MSM) structure is always accompanied by a high dark current due to the presence of abundant oxygen vacancy (V_{O}) defects [5, 9], which is generally believed as a donor in oxide materials and a tunneling defect at the metal/semiconductor Schottky contact [10, 11]. Bottom-gate thin-film transistor architecture has been constructed to electrically deplete the electrons in a- Ga_2O_3 channel by a negative gate voltage, [12, 13] but the fabrication process is more complicated compared with two-terminal devices. Therefore, it is worthwhile to develop a new strategy with chemical doping of a- Ga_2O_3 thin films to decrease the dark current while maintaining high photocurrent using simple MSM structure.

As a stubborn residual gas in vacuum chamber, hydrogen is often unintentionally doped into semiconductor materials [14], which can greatly affect the electrical properties [15, 16]. According to hybrid functional calculations, these hydrogen atoms are considered as shallow donors and responsible for the observed n-type conductivity in β - Ga_2O_3 [17]. In addition, hydrogen can also compensate acceptors like gallium vacancy and improve the conductivity of β - Ga_2O_3 [18, 19]. The above hydrogen behavior is investigated in crystalline β - Ga_2O_3 lattice and seldom explored in the amorphous phase. Nevertheless, hydrogen in amorphous indium gallium zinc oxide (a-IGZO) has been deliberately discussed both from theoretical and experimental viewpoints, where it acts as acceptors when forming metal-hydrogen bonds and donors when forming oxygen-hydrogen bonds [20, 21]. These results suggest that hydrogen doping in a- Ga_2O_3 film may also modulate its electrical conductivity and further improve the device performance.

In this work, intentional hydrogen-doped a- Ga_2O_3 films have been fabricated on quartz and polyethylene naphtholate (PEN) substrates by radio frequency (rf) magnetron sputtering technique. By *in-situ* tuning hydrogen flux subtly during sputtering process, the dark current of the optimal device is significantly decreased by about two orders of magnitude, exhibiting an excellent capability to detect weak UV light. In addition, flexible UV PDs on PEN substrate demonstrate great robustness in bending states and fatigue tests with comparable photoresponse as those on quartz substrate.

2. Method

Film growth: a- Ga_2O_3 films with thickness of 80–100 nm were deposited on quartz (500 μm thick) and PEN (125 μm thick) substrates at room temperature. The substrate-target distance is about 7 cm. The sputtering target is a pure Ga_2O_3 material (99.99%). During deposition, no O_2 gas is introduced. The quartz and PEN substrates were ultrasonically cleaned in acetone, alcohol, and deionized water successively and blown dry with nitrogen and then loaded into the growth chamber. The growth chamber was evacuated to the base pressure of 4.0×10^{-4} Pa before deposition. Four samples were grown on quartz substrates in a mixed atmosphere of H_2 :Ar = 0:10, 0.5:10, 2.0:10 and 5.0:10 sccm and named as S0, S1, S2 and S3, respectively. On PEN substrates, only one condition with H_2 flux of 0.5 sccm was adopted (P1). All of the above deposition processes lasted for 15 min under a sputtering power of 60 W and a total pressure of 0.4 Pa.

Device fabrication: Ga_2O_3 UV PDs were constructed with a coplanar MSM structure by conventional UV-lithography and lift-off technology. 100 nm ITO was deposited to form the transparent interdigital electrodes. These electrodes have 75 pairs of fingers with 5 μm in width, 5 μm in space and 300 μm in length. Thus, the total active area is about 0.45 mm^2 .

Material characterization: To determine the optical bandgap of these a- Ga_2O_3 films, transmittance spectrum was measured by using the Varian Cary 5000 UV–vis spectrophotometer. The surface morphology and roughness were evaluated by atomic force microscope (AFM, Bruker Dimension EDGE). X-ray diffractometer (XRD, Rigaku Smart Lab) was employed to confirm the amorphous nature of all the films. X-ray reflectivity (XRR) measurement was carried out on the same equipment to determine the density and thickness of all the films. Neutron reflection (NR) spectra were recorded using the non-polarized mode of multipurpose reflectometer, a time-of-flight neutron reflectometer ($2.5 < \lambda < 7$ Å), at China Spallation Neutron Source. The x-ray photoelectron spectroscopy (XPS, ESCALAB Xi+, ThermoFisher) was used to evaluate the chemical environment of a- Ga_2O_3 thin films prepared in different H_2 fluxes.

Device characterization: Keithley 6487 picoammeter was used to measure the dark current of all devices while Keithley 2400 was used to collect the electrical signals under light illumination. The light source was supplied by a hand-held 254 nm UV lamp. Photoresponsivity measurements were performed using a UV-enhanced Xenon lamp equipped with a monochromator, where optical power density is calibrated by a standard Si PD (Zolix).

3. Results

As exhibited in figure 1(a), all the samples on quartz substrates show a high transmittance over 85% above 300 nm and a strong UV absorption below 250 nm. The variation of optical bandgap is shown in the inset of figure 1(a), indicating an ignorable influence of hydrogen content on the bandgap and an excellent capability of UV light detection. The AFM image

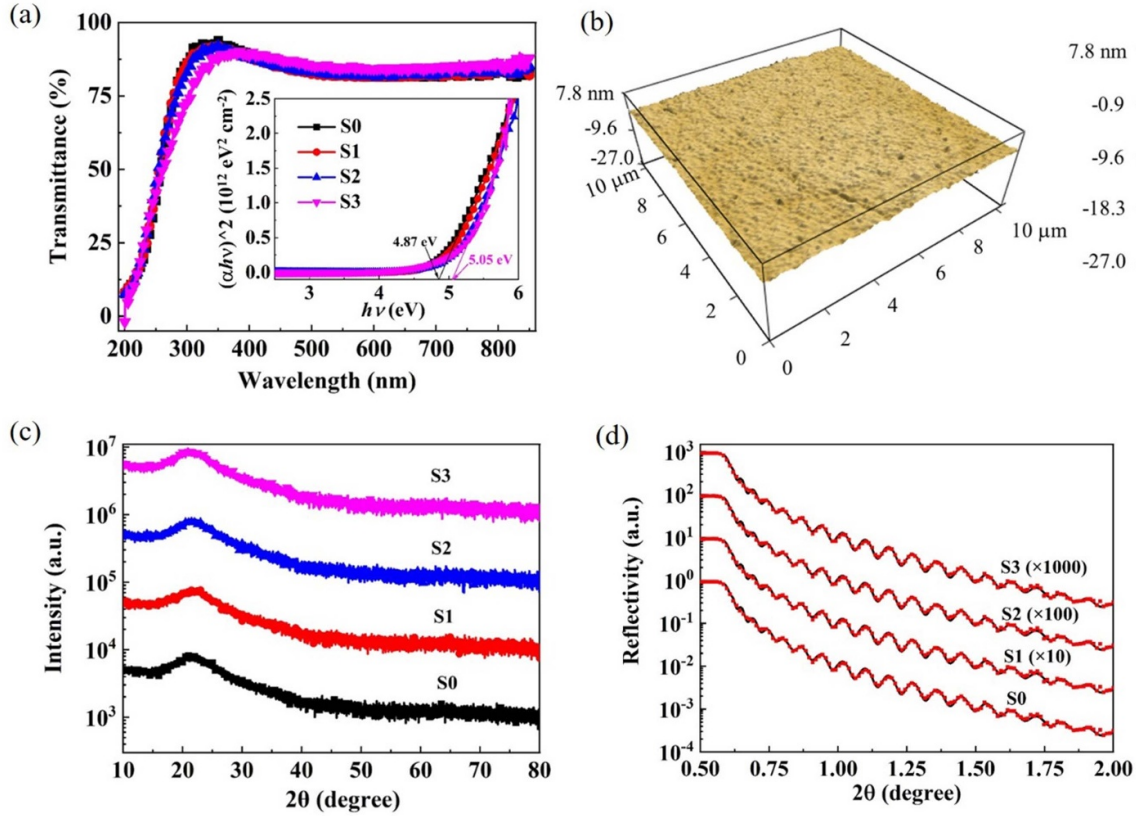


Figure 1. (a) The optical transmittance spectra of the a-Ga₂O₃ films on quartz. The inset shows the variation of optical bandgap. (b) AFM surface topography of a-Ga₂O₃ thin film grown on quartz substrate with 0.5 sccm H₂ (S1). (c) Grazing incident XRD curves of the a-Ga₂O₃ films. (d) XRR spectra and fitting curves of S0–S3 with different hydrogen fluxes.

of sample S1 is shown in figure 1(b) with the root mean square roughness of ~ 0.425 nm. The incorporation of hydrogen does not degrade the surface morphology apparently compared with the pure a-Ga₂O₃ as displayed in figure S1. Figure 1(c) shows the grazing incident XRD curves of all the samples. No signature peak is observed except a wide envelope at $\sim 21.5^\circ$, implying these thin films are amorphous without long-range order. In order to further explore the quality of the films, XRR measurement was carried out. By fitting the XRR experimental curves (figure 1(d)), the thickness as well as the mass density are determined as 84 nm/ 4.75 g cm^{-3} , 85 nm/ 5.34 g cm^{-3} , 93 nm/ 5.12 g cm^{-3} and 95 nm/ 4.80 g cm^{-3} for S0–S3, respectively. It can be found that the film density decreases while the thickness increases as the hydrogen flux rises from S1 to S3, implying that the *in-situ* hydrogen doping may change the local arrangement of atoms and cause an expansion of the nearest bond length in a-Ga₂O₃.

To confirm the existence of hydrogen in a-Ga₂O₃ thin films, NR measurement was employed since hydrogen can be easily detected with this technique. By using the GenX reflectometry analysis package, the experimental NR curves can be fitted to get the parameters of scattering length (B), particle number density (D) and scattering length density (SLD) [22, 23]. For hydrogen doped a-Ga₂O₃, B is defined as

$$B = 2B_{\text{Ga}} + 3B_{\text{O}} + nB_{\text{H}} \quad (1)$$

where B_{Ga} , B_{O} and B_{H} are the scattering length of gallium (7.288), oxygen (5.803) and hydrogen (-3.739), respectively [24]. SLD is defined as

$$\text{SLD} = \sum_j B_j D_j \quad (2)$$

where j runs over all kinds of atoms in the measured layers. Hence, SLD is an indicator of the film composition.

A two-layer model, including the interfacial transition layer and the main layer, was used to fit the experimental NR curves. This model is consistent with the nucleation process of physical vapor deposition, yielding the best fitting curves with uniform SLD values in the main layer and steep steps at the interface as shown in figure 2. It can be found that the value of B gradually decreases with the increase of hydrogen fluxes, indicating that hydrogen is effectively incorporated into the films, agreeing well with secondary ion mass spectrometry result shown in figure S2. It should be emphasized that even though there is no intentional hydrogen doping, the value of B for S0 is still lower than the standard value (31.985) for stoichiometric Ga₂O₃, which probably due to the presence of V_{O} defects in oxide thin films. [5] In addition, the value of D also decreases as the hydrogen flux increases, consistent with the XRR results shown in figure 1(c).

Based on the above thin films, UV PDs with simple MSM structure were fabricated to evaluate the impact of hydrogen on

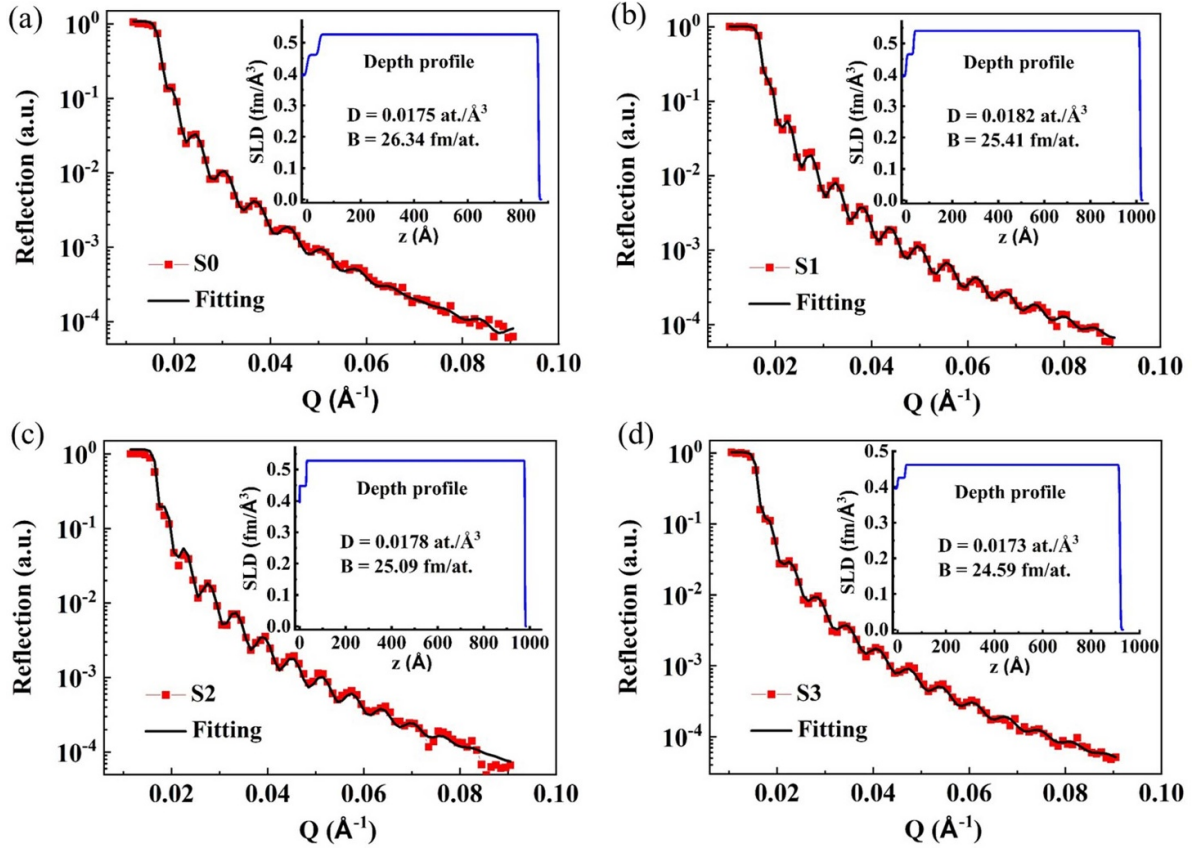


Figure 2. Experimental NR spectra and the corresponding fitting curves of all samples.

the photoresponse behavior. Figure 3(a) shows the I - V curves of the PDs in dark and under 254 nm UV light illumination. It can be clearly found that the photocurrent of S1 enhances several times while the dark current decreases nearly two orders of magnitude compared with S0, leading to a PDCR value larger than 10^7 . This behavior is quite different with the fact that both the dark current and photocurrent will decrease simultaneously if only the interfacial barrier height is enhanced according to previous reports where oxygen gas is introduced [5, 10]. More carriers must be excited into the conduction band. Since the bandgap is almost unchanged by hydrogen doping (figure 1(a)), the most probable origin of the extra carriers should come from the sub-bandgap states. However, the response speed does not change significantly as shown in figure 3(b), further implying the existence of abundant deep level traps. Therefore, the improvement of the photocurrent is tentatively ascribed to the new sub-bandgap states related with hydrogen doping.

In order to quantitatively assess the photoelectric performance of the H doped a-Ga₂O₃ PDs, key figure-of-merits for UV PDs, such as responsivity (R), detectivity (D^*) and external quantum efficiency (EQE) are calculated. The responsivity is defined as

$$R = \frac{I_{\text{photo}} - I_{\text{dark}}}{P_{\lambda} S} \quad (3)$$

where I_{photo} is the current under light illumination, I_{dark} is the dark current, P_{λ} is the power density of the incident light, and

S is the effective illumination area of the device. A standard Si photodiode is used to calibrate the power density of the incident light. Accordingly, EQE is calculated based on the equation in the below

$$\text{EQE} = \frac{hc}{q\lambda} R \times 100\% \quad (4)$$

(h is the Plank's constant, c is the velocity of light, q is the elemental charge and λ is the wavelength of light). In addition, D^* is expressed as

$$D^* = \frac{RS^{\frac{1}{2}}}{(2qI_{\text{dark}})^{\frac{1}{2}}} \quad (5)$$

Photoresponse spectra of all samples are recorded as shown in figure 3(c). Take the best sample S1 as an example. Its responsivity is as high as $3.20 \times 10^4 \text{ A W}^{-1}$ at around 254 nm, corresponding to the EQE of $1.57 \times 10^7\%$ and D^* of 5.28×10^{15} Jones, respectively. Such a high detectivity is attributed to the ultrahigh responsivity and ultralow dark current of the H-doped a-Ga₂O₃ UV PDs. In addition, the broadband photoresponse with a redshift of the peak position is observed even though the bandgap does not change a lot according to the transmittance spectra (figure 1(a)). The response from the longer wavelength should come from the excitation of the sub-bandgap states and band tails due to the presence of abundant defects and absence of long-range order.

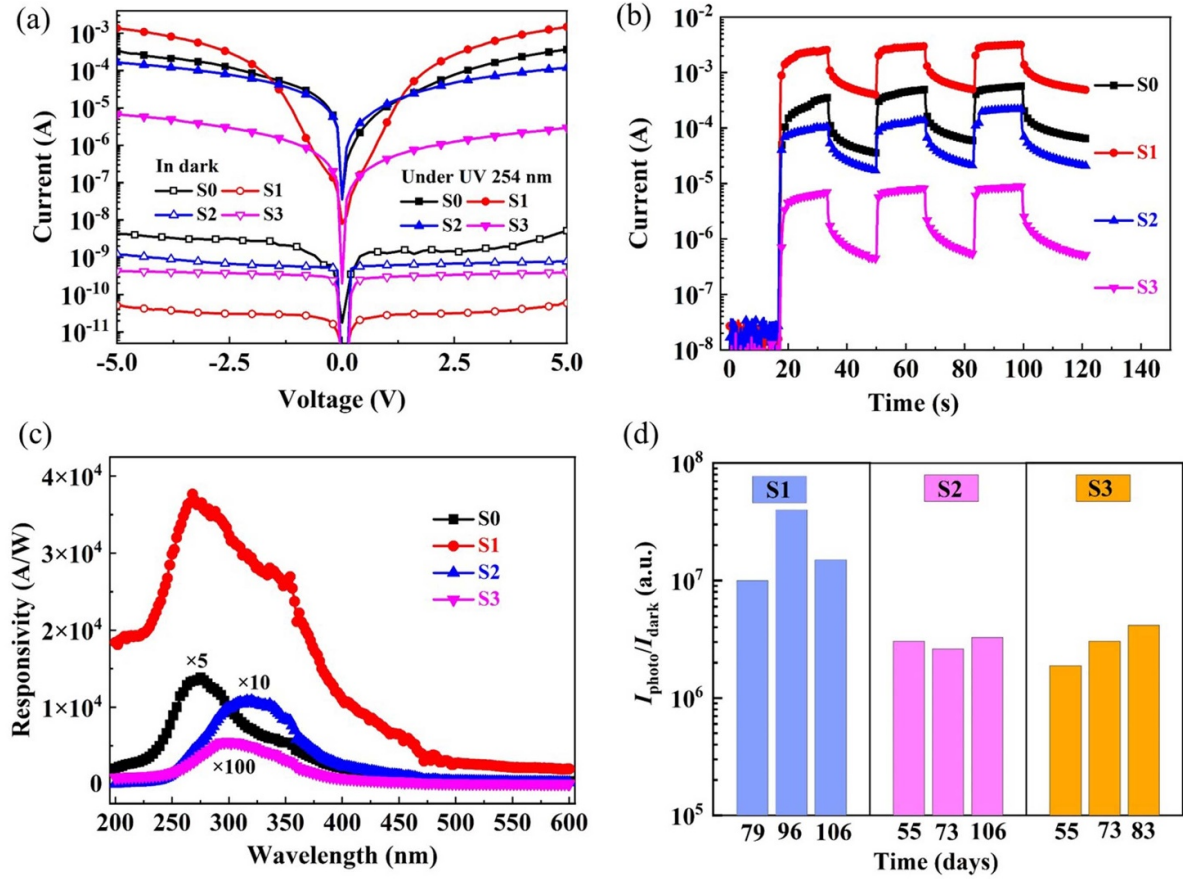


Figure 3. (a) The I - V curves in dark and under UV 254 nm light illumination. (b) Time-dependent photo-response of S0-S3 with the UV 254 nm light on and off at 10 V bias. (c) The photoresponsivity spectra of representative devices on sample S0-S3. (d) PDCR stability test within 3 months.

Table 1. Summarization of parameters for H doped a-Ga₂O₃ PDs.

Samples	I_{dark} @ 5 V (A)	I_{254} @ 5 V (A)	I_{254}/I_{dark} @ 5 V	Responsivity@254 nm (A W ⁻¹)	EQE @254 nm	D^* @254 nm (Jones)
S0	4.63×10^{-9}	2.26×10^{-4}	4.88×10^4	2.00×10^3	$9.81 \times 10^5\%$	3.49×10^{13}
S1	5.17×10^{-11}	1.37×10^{-3}	2.65×10^7	3.20×10^4	$1.57 \times 10^7\%$	5.28×10^{15}
S2	1.21×10^{-9}	1.65×10^{-4}	1.36×10^5	186.68	$9.13 \times 10^4\%$	6.36×10^{12}
S3	4.27×10^{-10}	6.74×10^{-6}	1.58×10^4	17.20	$8.42 \times 10^3\%$	9.87×10^{11}

This phenomenon has been reported in a-IGZO and a-Ga₂O₃ thin films previously [4, 25].

Further, to investigate the stability of the devices, a long-term follow-up test of about 3 months was carried out. All devices are placed in the drying cabinet without any passivation or encapsulation treatments. From figure 3(d), it can be seen that the PDCR values of all the devices are maintained at the original level with a slight decrease after about 100 d, ensuring a long-term service of the H-doped a-Ga₂O₃ UV PDs.

The parameters of all the representative devices on sample S0-S3 are summarized in table 1. With the increase of hydrogen flux, the dark currents show a trend of first decreasing and then increasing while the photocurrents show an opposite trend, resulting in the lowest dark current of 51.7 pA, highest photocurrent of 1.37 mA and highest PDCR value of 2.65×10^7 for sample S1. Therefore, a moderate hydrogen

content can effectively improve the device performance. A comparison of the photoresponse parameters with previously reported Ga₂O₃-based UV PDs is demonstrated in figure 4. Our a-Ga₂O₃ PD (S1) shows an ultra-high PDCR and responsivity simultaneously, surpassing most of the ever-reported results.

To better understand the influence of hydrogen doping on the device performance, XPS measurement was carried out. Figure 5 shows the core level spectra of Ga 2p and O 1s after calibration with C 1s peak (284.8 eV). In figure 5(a), two shoulder peaks, locating at 1149.0 eV and 1122.2 eV, appear at the high-energy side of the original Ga 2p_{1/2} (1145.6 eV) and Ga 2p_{3/2} (1119.0 eV) after hydrogen doping. Besides, the height of the shoulder peaks first increases and then decreases against the hydrogen flux, leading to the maximum value in S1. As to the O 1s curves shown in figure 5(b), the peak position

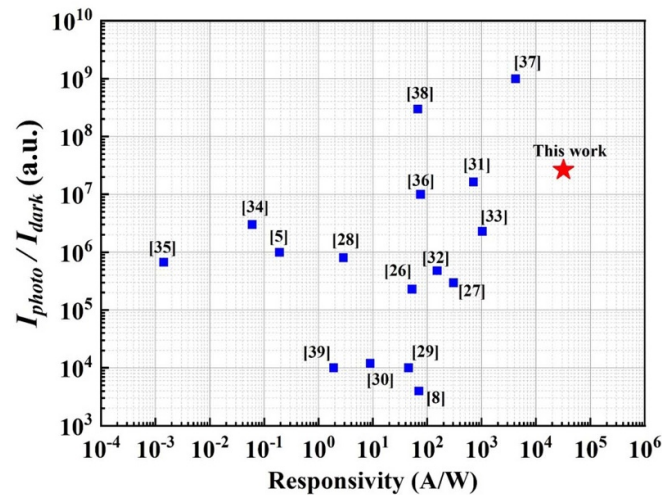


Figure 4. Comparison of the PDCR and responsivity of H-doped a-Ga₂O₃ UV PD in this work with other devices reported in the literatures [5, 8, 26–39].

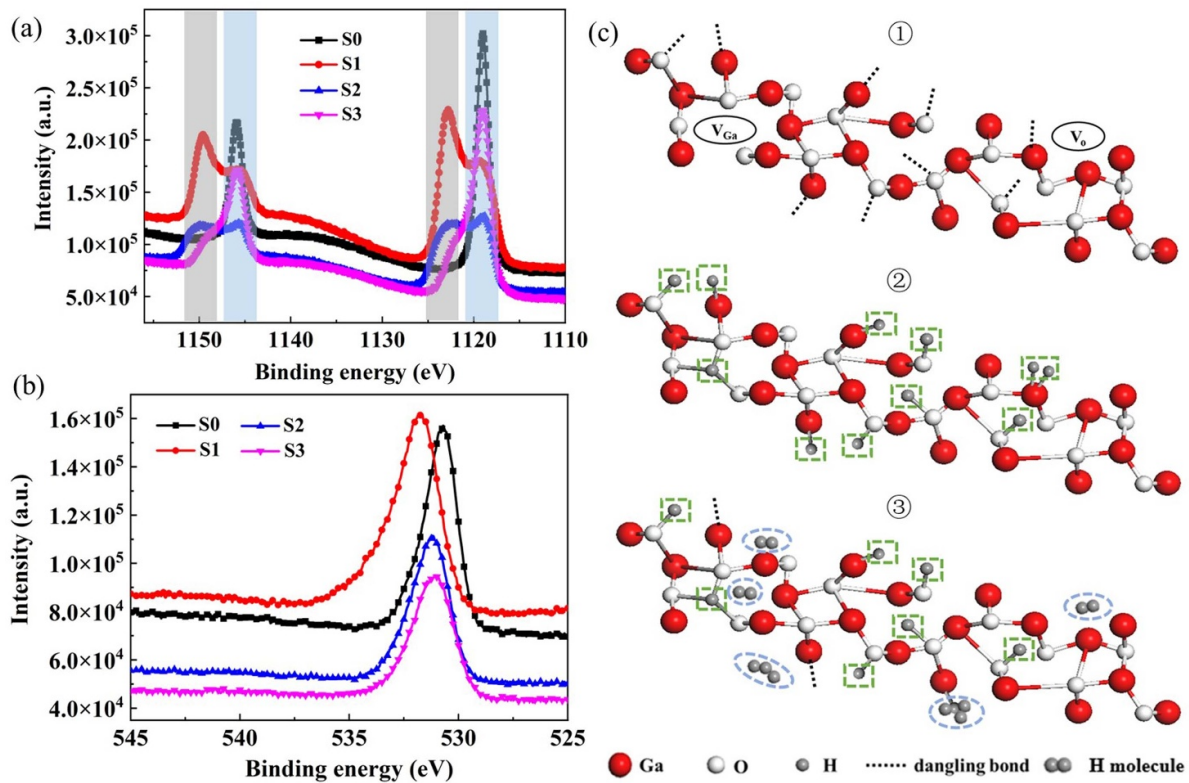


Figure 5. XPS curves of (a) Ga 2p and (b) O 1s for samples S0–S3. (c) A schematic diagram of the chemical bonds in a-Ga₂O₃ thin films deposited with different hydrogen fluxes. ① Initial a-Ga₂O₃ structure with random tilted chemical bonds, Ga/O vacancies and dangling bonds; ② with hydrogen flux of 0.5 sccm, most of the dangling bonds have been effectively passivated. ③ With higher hydrogen flux, the passivation effect is weakening due to the escape of H₂ molecules.

changes from 530.7 eV (S0) to 531.8 eV (S1) and then moves back to 531.0 eV for S2 and S3. As previously reported, a-Ga₂O₃ films grown in pure Ar environment often have a non-stoichiometric Ga/O ratio with more gallium dangling bonds than oxygen [5]. Despite of that, when a small amount of hydrogen (0.5 sccm) is introduced, these dangling bonds may be passivated by the formation of Ga–H and –OH couples, making the peak position of Ga 2p and O 1s move to the

higher binding energy [40]. Consequently, electrons from the dangling gallium atoms will be trapped by Ga–H bonds, leading to a lower dark current than the undoped sample S0. As the hydrogen flux increases, the radical hydrogen atoms in the plasma tend to combine with each other to form H₂ molecules and escape away from the films easily, making no contribution to or even weakening the passivation of the dangling Ga/O atoms. Consequently, the number of Ga–H and –OH

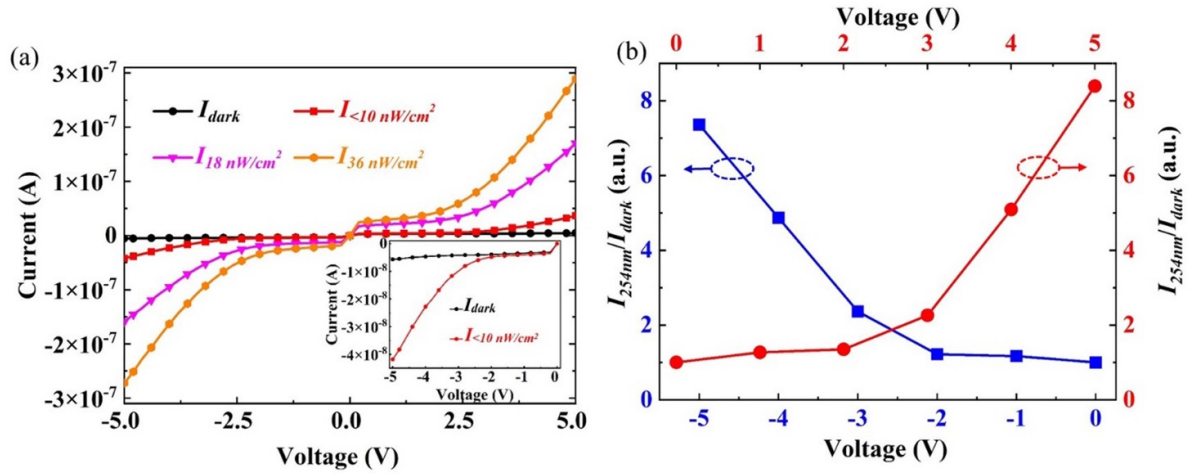


Figure 6. (a) I - V curves of S1 in dark and under UV 254 nm light illumination with different intensities. The inset is the enlarged negative part of the I - V curves in dark and under the weakest light illumination. (b) The variation of PDCR against the bias voltage for S1 sample under illumination lower than 10 nW cm^{-2} .

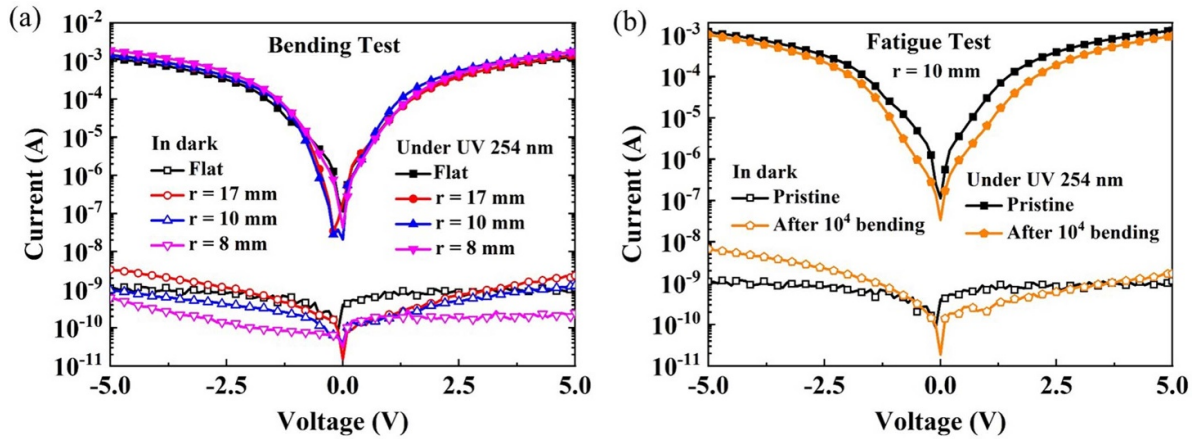


Figure 7. (a) I - V curves of P1 in dark and under 254 nm UV light illumination at flat and different bending states. (b) I - V curves of P1 in dark and under 254 nm UV light illumination before and after bending 10 000 cycles with $r = 10$ mm.

bonds also decreases, leading to a decrease of the shoulder peaks of Ga 2p and recovery of O 1s. A schematic diagram of the chemical bonds under different hydrogen fluxes has been shown in figure 5(c).

Further, photoresponse behavior under ultra-weak UV light was investigated for sample S1. Figure 6(a) shows the I - V curves in dark and under illumination of the UV 254 nm light with different intensities. The PDCR value can reach two orders of magnitude under the irradiation of a 36 nW cm^{-2} light source. Under the weakest light source ($<10 \text{ nW cm}^{-2}$), the PDCR is still nearly an order of magnitude as shown in the inset of figure 6(a). Besides, the dependence of PDCR value on the applied bias voltage under the weakest light is displayed in figure 6(b). It can be seen that the PDCR increases as the voltage increases both at the positive and negative biases. The

above results indicate the great potential of our UV PDs to be applied under extremely weak light sources.

At last, H-doped α -Ga₂O₃ UV PD was fabricated on PEN substrate using the same preparation condition as sample S1. This sample is named as P1. To investigate the flexibility of P1, I - V curves in dark and under UV 254 nm illumination were recorded in different bending states and after multiple bending cycles. As shown in figure 7(a), P1 exhibits almost the same photocurrent at different bending radius r ($r = 8, 10$ and 17 mm) as the flat state. However, the dark current fluctuates nearly one order of magnitude, probably due to the varying surface tensions and probe/electrode contacts under different bending states. Figure 7(b) compares the I - V curves in flat state before and after 10 000 bending cycles with $r = 10$ mm. Both the dark and photocurrent degrade a little bit within the

tolerable range. These results indicate the robustness of flexible a-Ga₂O₃ UV PD, promising the potential applications in flexible optoelectronic areas.

4. Conclusions

In summary, by precisely adjusting the flux of hydrogen gas during magnetron sputtering process, *in situ* H-doped a-Ga₂O₃ UV PDs with excellent performance have been developed both on the rigid quartz substrate and flexible PEN substrate. Based on the combined analysis with XRR, NR and XPS, it is suggested that the prevailing V_O defects in a-Ga₂O₃ thin films have been effectively passivated via the formation of Ga–H bonds, resulting in an obvious reduction of the dark current. The optimum device shows a remarkable detection ability under ultra-weak UV light irradiation (<10 nW cm⁻²), implying its potential application in various fields such as civil and national security. In addition, flexible UV PD has been achieved with the superiority of low cost, room-temperature detection, easy integration and mass production, demonstrating great prospect in flexible and transparent electronic fields.

5. Future perspectives

In this work, hydrogen-doped a-Ga₂O₃ thin films and the corresponding UV PDs have been achieved with a significant decrease of the dark current, providing a new way to improve the PDCR values of a-Ga₂O₃ UV PDs and endowing it the capability for ultra-weak light detection. In contrast to oxygen modulation, where the dark current and photocurrent decrease simultaneously as oxygen flux increases, a new defect may form after the incorporation of hydrogen atoms, which behaves like a killer of carriers under dark and a booster of carriers under light illumination. Although a series of measurements have been carried out, understanding of this new defects is still very limited since it is not easy to characterize a-Ga₂O₃ thin films with wide bandgap, high resistance and random atom arrangement, not to mention that detecting hydrogen is also a tough task. More brilliant characterization method as well as theoretical calculation of amorphous oxide semiconductors with hydrogen doping are definitely quite desirable. In addition, to promote the practical application of this device, the stability investigation must be executed further.

Acknowledgments

This work was supported by Guangdong Basic and Applied Basic Research Foundation (Grant Nos. 2022A1515110607 and 2019B1515120057), the National Natural Science Foundation of China (Grant Nos. 62174113, 12174275, 61874139, 61904201 and 11875088).

ORCID iD

Huili Liang  <https://orcid.org/0000-0002-5164-4290>

References

- [1] Chen X, Ren F, Gu S and Ye J 2019 Review of gallium-oxide-based solar-blind ultraviolet photodetectors *Photon. Res.* **7** 381
- [2] Pearton S J, Yang J, Cary P H, Ren F, Kim J, Tadjer M J and Mastro M A 2018 A review of Ga₂O₃ materials, processing, and devices *Appl. Phys. Rev.* **5** 011301
- [3] Chen X, Ren F-F, Ye J and Gu S 2020 Gallium oxide-based solar-blind ultraviolet photodetectors *Semicond. Sci. Technol.* **35** 023001
- [4] Liang H, Cui S, Su R, Guan P, He Y, Yang L, Chen L, Zhang Y, Mei Z and Du X 2019 Flexible x-ray detectors based on amorphous Ga₂O₃ thin films *ACS Photonics* **6** 351–9
- [5] Cui S, Mei Z, Zhang Y, Liang H and Du X 2017 Room-temperature fabricated amorphous Ga₂O₃ high-response-speed solar-blind photodetector on rigid and flexible substrates *Adv. Opt. Mater.* **5** 1700454
- [6] Zhou H, Zhang J, Zhang C, Feng Q, Zhao S, Ma P and Hao Y 2019 A review of the most recent progresses of state-of-art gallium oxide power devices *J. Semicond.* **40** 011803
- [7] Zhang D, Du Z, Ma M, Zheng W, Liu S and Huang F 2019 Enhanced performance of solar-blind ultraviolet photodetector based on Mg-doped amorphous gallium oxide film *Vacuum* **159** 204–8
- [8] Qian L-X, Wu Z-H, Zhang Y-Y, Lai P T, Liu X-Z and Li Y-R 2017 Ultrahigh-responsivity, rapid-recovery, solar-blind photodetector based on highly nonstoichiometric amorphous gallium oxide *ACS Photonics* **4** 2203–11
- [9] Lorenz M R, Woods J F and Gambino R J 1967 Some electrical properties of the semiconductor β-Ga₂O₃ *J. Phys. Chem. Solids* **28** 403–4
- [10] Zhang Y-F, Chen X-H, Xu Y, Ren F-F, Gu S-L, Zhang R, Zheng Y-D and Ye J-D 2019 Transition of photoconductive and photovoltaic operation modes in amorphous Ga₂O₃-based solar-blind detectors tuned by oxygen vacancies *Chin. Phys. B* **28** 028501
- [11] Liu L, Mei Z, Tang A, Azarov A, Kuznetsov A, Xue Q-K and Du X 2016 Oxygen vacancies: the origin of n-type conductivity in ZnO *Phys. Rev. B* **93** 235305
- [12] Han Z, Liang H, Huo W, Zhu X, Du X and Mei Z 2020 Boosted UV photodetection performance in chemically etched amorphous Ga₂O₃ thin-film transistors *Adv. Opt. Mater.* **8** 1901833
- [13] Qin Y et al 2019 Amorphous gallium oxide-based gate-tunable high-performance thin film phototransistor for solar-blind imaging *Adv. Electron. Mater.* **5** 1900389
- [14] Tang H, Ishikawa K, Ide K, Hiramatsu H, Ueda S, Ohashi N, Kumomi H, Hosono H and Kamiya T 2015 Effects of residual hydrogen in sputtering atmosphere on structures and properties of amorphous In-Ga-Zn-O thin films *J. Appl. Phys.* **118** 205703
- [15] King P D C and Veal T D 2011 Conductivity in transparent oxide semiconductors *J. Phys.: Condens. Matter* **23** 334214
- [16] McCluskey M D, Tarun M C and Teklemichael S T 2012 Hydrogen in oxide semiconductors *J. Mater. Res.* **27** 2190–8
- [17] Varley J B, Weber J R, Janotti A and van de Walle C G 2010 Oxygen vacancies and donor impurities in β-Ga₂O₃ *Appl. Phys. Lett.* **97** 142106
- [18] Varley J B, Peelaers H, Janotti A and van de Walle C G 2011 Hydrogenated cation vacancies in semiconducting oxides *J. Phys.: Condens. Matter* **23** 334212
- [19] Qin Y, Stavola M, Fowler W B, Weiser P and Pearton S J 2019 Editors' choice—hydrogen centers in β-Ga₂O₃: infrared spectroscopy and density functional theory *ECS J. Solid State Sci. Technol.* **8** Q3103
- [20] de Jamblinne de Meux A, Pourtois G, Genoe J and Heremans P 2018 Defects in amorphous semiconductors:

- the case of amorphous indium gallium zinc oxide *Phys. Rev. Appl.* **9** 054039
- [21] Ide K, Nomura K, Hosono H and Kamiya T 2019 Electronic defects in amorphous oxide semiconductors: a review *Phys. Status Solidi a* **216** 1800372
- [22] Chen H, Zhan X, Liu X, Hai Y, Xu J, Zhu T and Yin W 2019 The behavior of helium atoms in He^+ ion implanted W/Ni bilayer nanocomposite *Appl. Surf. Sci.* **486** 274–80
- [23] Li Q *et al* 2019 Impact of donor–acceptor interaction and solvent additive on the vertical composition distribution of bulk heterojunction polymer solar cells *ACS Appl. Mater. Interfaces* **11** 45979–90
- [24] Sears V F 1992 Neutron scattering lengths and cross sections *Neutron News* **3** 26–37
- [25] Kang Y, Song H, Nahm H-H, Jeon S H, Cho Y and Han S 2014 Intrinsic nature of visible-light absorption in amorphous semiconducting oxides *APL Mater.* **2** 032108
- [26] Li Z *et al* 2019 Flexible solar-blind Ga_2O_3 ultraviolet photodetectors with high responsivity and photo-to-dark current ratio *IEEE Photon. J.* **11** 1–9
- [27] Li Z *et al* 2019 Improving the production of high-performance solar-blind $\beta\text{-Ga}_2\text{O}_3$ photodetectors by controlling the growth pressure *J. Mater. Sci.* **54** 10335–45
- [28] Cui S-J, Mei Z-X, Hou Y-N, Chen Q-S, Liang H-L, Zhang Y-H, Huo W-X and Du X-L 2018 Enhanced photoresponse performance in $\text{Ga}/\text{Ga}_2\text{O}_3$ nanocomposite solar-blind ultraviolet photodetectors *Chin. Phys. B* **27** 067301
- [29] Lee S H, Kim S B, Moon Y-J, Kim S M, Jung H J, Seo M S, Lee K M, Kim S-K and Lee S W 2017 High-responsivity deep-ultraviolet-selective photodetectors using ultrathin gallium oxide films *ACS Photonics* **4** 2937–43
- [30] Chen Y, Lu Y, Liao M, Tian Y, Liu Q, Gao C, Yang X and Shan C 2019 3D solar-blind Ga_2O_3 photodetector array realized via origami method *Adv. Funct. Mater.* **29** 1906040
- [31] Lu Y, Krishna S, Tang X, Babatatin W, Ben Hassine M, Liao C-H, Xiao N, Liu Z and Li X 2022 Ultrasensitive flexible κ -phase Ga_2O_3 solar-blind photodetector *ACS Appl. Mater. Interfaces* **14** 34844–54
- [32] Wang Y, Xue Y, Su J, Lin Z, Zhang J, Chang J and Hao Y 2022 Realization of cost-effective and high-performance solar-blind ultraviolet photodetectors based on amorphous Ga_2O_3 prepared at room temperature *Mater. Today Adv.* **16** 100324
- [33] Ji X, Yin X, Yuan Y, Yan S, Li X, Ding Z, Zhou X, Zhang J, Xin Q and Song A 2023 Amorphous Ga_2O_3 Schottky photodiodes with high-responsivity and photo-to-dark current ratio *J. Alloys Compd.* **933** 167735
- [34] Sui Y, Liang H, Huo W, Wang Y and Mei Z 2020 A flexible and transparent $\beta\text{-Ga}_2\text{O}_3$ solar-blind ultraviolet photodetector on mica *J. Phys. D: Appl. Phys.* **53** 504001
- [35] Wu C, Wu F, Ma C, Li S, Liu A, Yang X, Chen Y, Wang J and Guo D 2022 A general strategy to ultrasensitive Ga_2O_3 based self-powered solar-blind photodetectors *Mater. Today Phys.* **23** 100643
- [36] Zhang C *et al* 2023 High-performance fully transparent Ga_2O_3 solar-blind UV photodetector with the embedded indium–tin–oxide electrodes *Mater. Today Phys.* **33** 101034
- [37] Zhu R, Liang H, Bai H, Zhu T and Mei Z 2022 Double is better: achieving an oxide solar-blind UV detector with ultrahigh detectivity and fast-refreshing capability *Appl. Mater. Today* **7** 101556
- [38] Hou X *et al* 2022 High-performance harsh-environment-resistant GaO_x solar-blind photodetectors via defect and doping engineering *Adv. Mater.* **34** 2106923
- [39] He H, Wu C, Hu H, Wang S, Zhang F, Guo D and Wu F 2023 Bandgap engineering and oxygen vacancy defect electroactivity inhibition in highly crystalline N-alloyed Ga_2O_3 films through plasma-enhanced technology *J. Phys. Chem. Lett.* **14** 6444–50
- [40] Bang J, Matsuishi S and Hosono H 2017 Hydrogen anion and subgap states in amorphous In-Ga-Zn-O thin films for TFT applications *Appl. Phys. Lett.* **110** 232105